

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Shinya MYOJIN, et al.

Serial No. 10/644,220

Group Art Unit: 1742

Confirmation No. 6469

Filed: August 21, 2003

Examiner: Sikyin IP

For: COPPER-NICKEL-SILICON TWO PHASE QUENCH SUBSTRATE

**AMENDMENT/RESPONSE**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment/Response is being filed during/after a three month suspension to February 6, 2007.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.